

Application/Control No.	Applicant(s)/Patent under Reexamination
10/662,382	KANAI ET AL.
Examiner	Art Unit
Chris C. Chu	2815

SEARCHED					
Class	Subclass	Date	Examiner		
257	E23.079, E23.171, 700 & 737	12/4/2006	C.C.		
257	776 - 781	12/4/2006	C.C.		
257	773 & 774	12/4/2006	C.C.		
257	758 & 688	12/4/2006	C.C.		
257	690 & 692	12/4/2006	C.C.		
438	108 & 113	12/4/2006	C.C.		
438	123 & 612	12/4/2006	C.C.		
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INTERFERENCE SEARCHED					
Subclass	Date	Examiner			
as above	12/4/2006	c.c.			
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	Subclass	Subclass Date			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Searched in US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; FPRS; and IBM_TDB;	12/4/2006	c.c.		
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